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## \*\* CONTINUING DATA \*\*\*\*\*

This application is a DIV of 09/818,713 03/28/2001 PAT 6,687,013 *MM*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2000-89556 03/28/2000 *MM*

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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| Foreign Priority claimed<br><input checked="" type="checkbox"/> yes <input type="checkbox"/> no   | STATE OR | SHEETS  | TOTAL  | INDEPENDENT |
| 35 USC 119 (a-d) conditions met<br><input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance | COUNTRY  | DRAWING | CLAIMS | CLAIMS      |
| Verified and Acknowledged<br>Examiner's Signature <i>MM</i> Initials <i>MM</i>  | JAPAN    | 19      | 2      | 2           |

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## TITLE

Laser interferometer displacement measuring system, exposure apparatus, and electron beam lithography apparatus

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|-----------------------------------|---|--|
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